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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Makoto
Family Name::	IIDA
City of Residence::	Fukushima
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number::	25944
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Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	A METHOD FOR PRODUCING SEMICONDUCTOR WAFERS AND A SYSTEM FOR DETERMINING A CUT POSITION IN A SEMINCONDUCTOR INGOT
Attorney Docket Number::	128768
Suggested Drawing Figure::	1
Total Drawing Sheets::	3
Small Entity::	No

Representative Information

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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Phase of	PCT/JP2005/000641	01/20/05
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-026887	02/03/04	Yes
Assignee Information			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2, Marunouchi 1-chome	
City of mailing address::		Chiyoda-ku	
State or Province of mailing address::		Tokyo	
Country of mailing address::		Japan	